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**THIRD
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 1 of 1

Application Number	10/575,987
Filing Date	April 17, 2006
First Named Inventor	Hiroshi Touge et al.
Examiner Name	DANIEL T PIHULIC
Attorney Docket No.	1011695-000006

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	STATUS						
					Translation	Partial Translation	Eng. Lang. Summary	Search Report	Official Action	Abstract	Cited in Spec
	2-276308**		JP (Corr. to USP 5,227,667)	11-13-1990					X	X	
	11-205116**	A	JP	07-30-1999					X	X	
	2000-017916**	A	JP(Corr. to USP 6,281,599B1)	01-18-2000					X	X	
	11-231065**	A	JP	08-27-1999					X	X	
	S53-118996**		JP	10-17-1978					X	X	
	2002-342031**	A	JP	11-29-2002					X	X	
	WO 92/24579	A1	International	10-27-1994					X		

**PATENT FAMILY SEARCH PROVIDED

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	Official Action (Notice of Reasons of Rejection) issued by the Japanese Patent Office in priority application number JP 2003-358227, July 17, 2007; and English translation thereof
	Official Action (Notice of Reasons of Rejection) issued by the Japanese Patent Office in priority application number JP 2003-358228, July 17, 2007; and English translation thereof
	Official Action (Notice of Reasons of Rejection) issued by the Japanese Patent Office in priority application number JP 2003-363422, July 17, 2007; and English translation thereof
	Official Action (Notice of Reasons of Rejection) issued by the Japanese Patent Office in priority application number JP 2003-370556, July 17, 2007; and English translation thereof
	Official Action issued by the Korean Intellectual Property Office in corresponding Korean Patent Application No. 10-2006-7006870

Examiner Signature	/Dan Pihulic/	Date Considered	08/25/2008
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /DTP/